

<b>Notice of References Cited</b>	Application/Control No. 10/779,864	Applicant(s)/Patent Under Reexamination KRIJNEN, EDWIN EDUARD NIC	
	Examiner Samuel A. Turner	Art Unit 2877	Page 1 of 1

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*	B	US-6,285,457	09-2001	Ukaji, Takao	356/500
*	C	US-6,875,992	04-2005	Castenmiller et al.	250/548
*	D	US-6,876,453	04-2005	Van Doren et al.	356/498
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Peggs et al, Design for a Compact High-Accuracy CMM, CIRP Annals, vol. 48/1, 1/1999, pp. 417-421.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.